TRANSMITTAL

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of
Invention

Wafer Holder for Semiconductor Manufacturing Equipment and Semiconductor Manufacturing Equipment in Which It Is Installed

Application Number:

Date:

First Named Applicant:

Mr. Masuhiro Natsuhara

Confirmation Number:

Attorney Docket Number:

39.016-C

I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.

I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.

Submitted By:	Elec. Sign.	Sign. Capacity
James Judge	jjUDGE	Agent
Registered Number: 42,701		

Documents being submitted:	Files
us-assignment	SM016CIP-usassn.xml
•	us-assignment.xsl
	us-assignment.dtd
	assgn.tif
us-request	SM016CIP-usrequ.xml
	us-request.dtd
	us-request.xsl
us-fee-sheet	SM016CIP-usfees.xml
	us-fee-sheet.xsl
	us-fee-sheet.dtd
us-declaration	dclr01.tif
application-body	SM016CIP-trans.xml
	us-application-body.xsl
	application-body.dtd
	wipo.ent
	mathml2.dtd
	mathml2-qname-1.mod
	isoamsa.ent
	isoamsb.ent
	isoamsc.ent
	isoamsn.ent
	isoamso.ent
	isoamsr.ent
	isogrk3.ent
	isomfrk.ent
	isomopf.ent
	isomscr.ent
	isotech.ent
	isobox.ent
	isocyr1.ent
	isocyr2.ent
	isodia.ent
	isolat1.ent
	isolat2.ent
	isonum.ent
	isopub.ent
	mmlextra.ent
	mmlalias.ent
	soextblx.dtd
	sheet01.tif
	sheet02.tif
us-declaration	dclr02.tif
us-declaration	dclr03.tif
Comments	